TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))				Docket No. SEC.1101			
In Re Application Of: Ki-Hwan PARK et al.							
	Serial No.	Examiner	Group Art Unit				
	NEW	OCTOBER 30, 2003	TO BE ASSIGNED		TO BE ASSIGNED		
Title: METHOD OF AND APPARATUS FOR CLEANING SEMICONDUCTOR WAFERS							
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450							
		37 C	FR 1.97(b)				
×	The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.						
		37 C	FR 1.97(c)				
	The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:						
	☐ the statem	nent specified in 37 CFR 1.97(e)	;				
OR							
	□ the fee se	t forth in 37 CFR 1.17(p).					
	Re A	Serial No. NEW The Information of a national ap three months of application; before Action after the formation CFR 1.97(b), prinal Action uncotherwise closes the statent in the statent	(Under 37 CFR 1.97(b) or 1.97 Re Application Of: Ki-Hwan PARK et al. Serial No. Filing Date NEW OCTOBER 30, 2003 Ide: METHOD OF AND APPARATUS FOR CLEANING ACCOMMISSION P.C. Alexandria 37 C ☑ The Information Disclosure Statement submitted of a national application other than a continued three months of the date of entry of the national application; before the mailing of a first Office Accommandation after the filing of a request for continued entry of the national application after the filing of a request for continued entry of the national application; before the mailing of a first Office Accommandation after the filing of a request for continued entry of the national application; before the mailing of a first Office Accommandation application; and a request for continued entry of the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(b), provided that the Information Disclosure Statement submitted CFR 1.97(c), provided that the Information Disclosure Statement submitted CFR 1.97(c), provided that the Information Disclosure Statement submitted CFR 1.97(c), provided that the Information Disclosure Statement submitted CFR 1.97(c), provided that the Information Disclosure Statement submitted CFR 1.97(c), provided that the Information Disclosure Statement submitted CFR 1.97(c), provided that the Information Disclosure Statement State	(Under 37 CFR 1.97(b) or 1.97(c)) Re Application Of: Ki-Hwan PARK et al. Serial No. Filing Date Examiner NEW OCTOBER 30, 2003 TO BE ASSIGNED He: METHOD OF AND APPARATUS FOR CLEANING SEMICONDUCTOR WAFF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 37 CFR 1.97(b) The Information Disclosure Statement submitted herewith is being filed within of a national application other than a continued prosecution application under three months of the date of entry of the national stage as set forth in 37 CFR application; before the mailing of a first Office Action on the merits, or before the Action after the filing of a request for continued examination under 37 CFR 1.1: 37 CFR 1.97(c) The Information Disclosure Statement submitted herewith is being filed after the CFR 1.97(b), provided that the Information Disclosure Statement is filed before Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1 otherwise closes prosecution in the application, and is accompanied by one of: the statement specified in 37 CFR 1.97(e); OR	(Under 37 CFR 1.97(b) or 1.97(c)) Re Application Of: Ki-Hwan PARK et al. Serial No. Filing Date Examiner NEW OCTOBER 30, 2003 TO BE ASSIGNED The METHOD OF AND APPARATUS FOR CLEANING SEMICONDUCTOR WAFERS Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 37 CFR 1.97(b) The Information Disclosure Statement submitted herewith is being filed within three of a national application other than a continued prosecution application under 37 three months of the date of entry of the national stage as set forth in 37 CFR 1.49 application; before the mailing of a first Office Action on the merits, or before the ma Action after the filing of a request for continued examination under 37 CFR 1.114. 37 CFR 1.97(c) The Information Disclosure Statement submitted herewith is being filed after the pe CFR 1.97(b), provided that the Information Disclosure Statement is filed before the Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311 otherwise closes prosecution in the application, and is accompanied by one of: the statement specified in 37 CFR 1.97(e); OR		

	OSURE STATEMENT 7(c))	Docket No. SEC.1101					
In Re Application: Ki-Hwan PARK et al.							
Serial No.	Filing Date	Examiner	Group Art Unit				
NEW	OCTOBER 30, 2003	TO BE ASSIGNED	TO BE ASSIGNED				
METHOD OF AND APPARATUS FOR CLEANING SEMICONDUCTOR WAFERS							
	•	ment of Fee ects to pay the fee set forth in 37 CFR 1.17					
☐ The Director is he as described beloud ☐ Charge the ☐ Credit and ☐ Charge a Certificate of Total I certify that this document account is being facsing the compact of the compact of the compact of the certificate of the	The Director is hereby authorized to charge and credit Deposit Account as described below. ☐ Charge the amount of ☐ Credit any overpayment. ☐ Charge any additional fee required. Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail ☐ Certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (Fε ☐ I certify that this document and fee is being deposited on with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.						
	Signature Signature of Per						
Typed or Printed N	ame of Person Signing Certificate	Typed or Printed Name of Person	of Person Mailing Certificate				
		Dated: OCTOBER 30, 2003					

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number				
SEC.1101	NEW				
Applicant(s)					
Ki-Hwan Park et al.					
Filing Date	Group Art Unit				
OCTOPED 20 2002	TO DE ACCIONED				

				Filing Date Group Art Unit OCTOPED 20, 2002						
				<u></u>	CTOBER 30, 2003 TO BE ASSIGNED					
	т—			U.S. PAT	ENT DOCUMENTS					
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME	CLASS	SUBCLASS		FILING DATE IF APPROPRIATE	
	A	6,394,110	05/28/2002	KAMIF	KAWA et al.					
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	REF	DOCUMENT NUMBER	DATE		COUNTRY	CLASS	SUBCLASS	Tran	slation	
					COUNTRI	Christ	SUBCLASS	YES	NO	
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				<u> </u>						
				OTHER I	DOCUMENTS (Including	¿ Author, Title, I	Date, Pertinent Pag	ges, Etc.)		
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EXAMINE	R				DATE CONSIDERED					
EXAMINE	R: Initi	ial if citation considered, whether o	or not citation is in	conformance	ce with MPEP Section 609; [Draw line throug	gh citation if not i	in conforma	nce and not	

Form PTO-A820 (als form PTO-1449)

considered. Include copy of this form with next communication to applicant.

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